



ZFW

Docket Number: 081468-0308588  
Client Reference: P-1827.000-US

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

MICHAEL VAN DER VEEN, et al. Group Art Unit: 2829

Application No.: 10/790,252 Examiner: UNKNOWN

Filed: March 2, 2004 Confirmation No.: 9805

For: LITHOGRAPHIC APPARATUS, METHOD OF SUBSTRATE IDENTIFICATION, DEVICE MANUFACTURING METHOD, SUBSTRATE, AND COMPUTER PROGRAM

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. One copy of the reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO-1449 to Applicants with the next Office communication to indicate that the reference has been considered, per MPEP § 609.

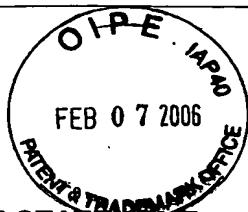
This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

Guillermo E. Baeza  
Registration Number 35056  
Customer Number: 00909

Date: February 7, 2006  
PILLSBURY WINTHROP SHAW PITTMAN LLP  
Telephone: (703) 770-7900  
Facsimile: (703) 770-7901  
P.O. Box 10500  
McLean, VA 22102

FORM PTO-1449 (modified)  
 To: U.S. Department of Commerce  
 (PW FORM PAT-1449)  
 Patent and Trademark Office



Atty. Dkt. No.	M#	Client Ref.
	0308588	P-1827.000-US
Applicant: VAN DER VEEN et al.		
Appln. No.: 10/790,252		
Filing Date: March 2, 2004		
Examiner: UNKNOWN		Group Art Unit: 2829

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Date: February 7, 2006

Page **1** of **1**

**U.S. PATENT DOCUMENTS**

Examiner's Initials*	Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
AR						
BR						
CR						
DR						
ER						
FR						
GR						
HR						
IR						
JR						
KR						
LR						

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract	Translation Readily Available
						Enclosed	No
MR							
NR							
OR							
PR							
QR							
RR							
SR							
TR							
UR							
VR							

**OTHER (Including in this order: Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

WR	"Matrix coding for optical identification of die", Research Disclosure Database Number 467095 (March 2003)	X
XR		
YR		
ZR		
AAR		
BBR		

Examiner \_\_\_\_\_ Date Considered: \_\_\_\_\_

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.